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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1795
PATENT**

OK TO ENTER: /SR/ 03/11/2008

Attorney Docket No. 04329.3304-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Ayako NAKANO et al.)	Group Art Unit: 1795
)	
Application No.: 10/823,539)	Examiner: Stephen D. ROSASCO
)	
Filed: April 14, 2004)	Confirmation No.: 4440
)	
For: PATTERN FORMING METHOD AND)	
SYSTEM, AND METHOD OF)	
MANUFACTURING A)	
SEMICONDUCTOR DEVICE)	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION

In reply to the final Office Action mailed November 6, 2007, the period for response to which extends through February 6, 2008, Applicants respectfully request reconsideration of the above-identified application in light of the following remarks.